

Amendments to the Abstract

Please amend the original abstract (page 184) as follows.

ABSTRACT OF THE DISCLOSURE

The present invention relates to a A revolution member supporting apparatus holds and rotates for holding and rotating a disc-shaped object (object to be rotated) such as a semiconductor wafer. The A revolution member supporting apparatus includes, comprising: a rotatable member which rotates about an axis of rotation; rotation, and a plurality of holding members which are disposed along a circle having a center corresponding to the axis of rotation of the rotatable member, and which revolve around the axis of rotation when the rotatable member rotates; rotates, wherein the holding members are allowed to swing about their own central axes.